Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/005,959	PEEV ET AL.	
Examiner	Art Unit	
J. Derek Rutten	2192	

	SEARCHED				
Class	Subclass	Date	Examiner		
717	136,174	9/9/2005	JDR		
707	202	9/9/2005	JDR		
704	15	9/9/2005	JDR		
		!			

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
717	136,174	9/9/2005	JDR		
707	202	9/9/2005	JDR		
704	15	9/9/2005	JDR		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB) - see search history printout	8/17/2005	JDR
717/168-178 - text search only - see search history printout	8/23/2005	JDR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB) - see search history printout	8/23/2005	JDR
USPN 6366898	8/24/2005	JDR
Chameli Das (consulted re. allowability)	9/9/2005	JDR
ACM - portal.acm.org IEEE - ieeexplore.ieee.org (see search history printout)	9/9/2005	JDR
EAST (US-PGPUB; USPAT; EPO; JPO; IBM_TDB) - see search history printout	9/9/2005	JDR